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## \*BIBDATASHEET\*

CONFIRMATION NO. 9134

Bib Data Sheet

SERIAL NUMBER 09/988,704	FILING DATE 11/20/2001  RULE	CLASS 382	GROUP ART UNIT 2625 ✓	ATTORNEY DOCKET NO. 2001_1718A
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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

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\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
JAPAN 2000-354471 11/21/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
\*\* 12/03/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 18	TOTAL CLAIMS 15 ✓	INDEPENDENT CLAIMS 2 ✓
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>12/23/04</i>				

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TITLE  
Method and apparatus for correcting inclination of IC on semiconductor wafer

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of
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